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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Warren M. Farnworth

Serial No.: 10/663,944

Filed: September 16, 2003

For: STEREOLITHOGRAPHIC METHOD
FOR FORMING INSULATIVE COATINGS
FOR VIA HOLES IN SEMICONDUCTOR
DEVICES, INSULATIVE COATINGS SO
FORMED, SYSTEMS FOR FORMING THE
INSULATIVE COATINGS, AND
SEMICONDUCTOR DEVICES
INCLUDING VIA HOLES WITH THE
INSULATIVE COATINGS

Confirmation No.: 3861

Examiner: William M. Brewster

Group Art Unit: 2826

Attorney Docket No.: 2269-5700US
(02-1183.00/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

November 9, 2004
Date

Signature

Denise Dyer
Name (Type/Print)

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

This Amendment is being filed in response to the Office Action mailed on August 9, 2004, the three-month shortened statutory period for response to which expires on November 9, 2004.

Amendments to the claims are set forth in the listing of the claims, which begins on page 2 of this paper; and

Remarks start at page 9 of this paper.